

<b>Notice of References Cited</b>	Application/Control No. 10/537,158	Applicant(s)/Patent Under Reexamination BISCARINI ET AL.	
	Examiner Elizabeth Whitehead	Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/047272	11-2002	Chen et al.	365/151
*	B	US-6,827,979	12-2004	Mirkin et al.	427/256
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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	U	Cavallini et al., "Information Storage Using Supramolecular Surface Patterns", January 24, 2003, Science Magazine, Vol. 299, p. 531.
	V	Cavallini et al., "Conformational Self-Recognition as the Origin of Dewetting in Bistable Molecular Surfaces", October 11, 2001, American Chemical Society, J. Phys. Chem. B 2001, 105, 10826-10830.
	W	Michel et al. "Printing meets lithography: Soft approaches to high-resolution patterning", September 5, 2001, IBM, J. Res. Dev., Vol. 45, p. 697-719.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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